



بسم الله الرحمن الرحيم

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Physics Department
Faculty of Science
Ain Shams University

Investigation of Some Factors Affecting the Efficiency of Solid State Nuclear Track Detectors for Alpha-Particles

**A Thesis Submitted in Partial Fulfillment of the
Requirements for the Degree Of
Master of Science in physical degree**

**By
Magda Naeem Habib**

**Physics Department
Faculty of Science, Ain Shams University
Egypt**

Supervisors

Prof. Dr. Nabil Ali El-Faramawy Professor of Nuclear and Radiation Physics Physics Department, Ain Shams University	Prof. Dr. Arafa Ibrahim Abd El-Hafez Professor of Ionizing Radiation Metrology Laboratory National Institute for Standards
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Faculty of Science
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Name: Magda Naeem Habib

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Thesis supervisor:

1-Prof. Dr. Nabil Ali El-Faramawy

Professor of Nuclear and Radiation Physics
Physics Department
Ain Shams University

2- Prof. Dr. Arafa Ibrahim Abd El-Hafez

Professor of Ionizing Radiation Metrology
Ionizing Radiation Metrology Department
Laboratory National Institute for Standards

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2- Prof. Dr. Arafa Ibrahim Abd El-Hafez
Professor of Ionizing Radiation Metrology
Ionizing Radiation Metrology Department

Examination committee

1- Prof. Dr. Nabil Ali El-Faramawy *Professor of Nuclear
and Radiation Physics - Physics Department - Ain Shams University*

2- Prof. Dr. Arafa Ibrahim Abd El-Hafez *Professor of Ionizing
Radiation Metrology - Ionizing Radiation Metrology Department -
Laboratory National Institute for Standards*

3-Prof. Dr. Mohamed El-Sayed El-Nagdy *Professor of Nuclear
and Radiological Physics - Department of Physics - Faculty of Science -
Helwan University*

4- Prof. Dr. Tarek Mohamed El-Desouky *Professor of Nuclear
Physics - Department of Physics - College of Girls - Ain Shams
University*

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Approval of Faculty Council
/ / 2022

Date of Approval
/ / 2022

Approval of Faculty Council
/ / 2022

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CONTENTS	Page
LIST OF FIGURES	I
LIST OF TABLES	IX
LIST OF SAMPLES	X
SUMMARY	XII
CHAPTER ONE: THEORETICAL ASPECTS	
1.1. ENERGETIC ION INTERACTIONS WITH POLYMERS	1
1.2. SOLID STATE NUCLEAR TRACK DETECTORS	3
1.2.1. Principles of SSTNDs	3
1.2.2. Formation of Particle Tracks	4
1.3. TYPES OF SOLID-STATE NUCLEAR TRACK DETECTORS	4
1.3.1. Inorganic Detectors	4
1.3.2. Organic Detectors	5
1.4. TRACK FORMATION MECHANISMS	5
1.5. TRACK FORMATION MECHANISM MODELS	6
1.5.1. Ion-Explosion Spike Model	6
1.5.2. Radiochemical Damage Mechanism Model	7
1.6. TYPE OF DETECTORS	8
1.6.1. CR-39 Detectors	8
1.6.2. LR-115 Detectors	9
1.7. THE CHEMICAL ETCHING	10
1.8. GEOMETRY OF THE TRACK	11
1.9. KEEP TRACK OF THE VARIABLES THAT HAVE AN IMPACT.	12
1.9.1 The Bulk Etch Rate Velocity (V_B)	12
1.9.2. The Track Etch Rate Velocity (V_T)	13
1.9.3. Engraving Sensitivity and Efficiency	14

1.10. VISUALIZATION AND EVALUATION OF THE TRACK	15
1.10.1. Electron Microscope	15
1.10.2. Optical Microscope	15
1.11. THE BENEFITS OF SSNTD'S	16
1.11.1. SSNTDs have a Disadvantage.	16
1.12. FLUX DENSITY FOR DIFFERENT SOURCE GEOMETRY	17
1.12.1. Point Source S	18
1.12.2. Line Source S_L	19
1.12.3. Area Source S_A	21
1.12.4: Slab Source Infinite	22
1.12.5: Spherical Source	24
CHAPTER TWO: LITERATURE SURVEY	
2.1. PREVIOUS WORK	25
CHAPTER THREE: EXPERIMENTAL TECHNIQUES	
3.1. MATERIALS USED	56
3.1.1. Radioactivity Source and Irradiation Method	56
3.1.2. The Radioactive Decay Equation	57
3.1.3. The Activity	57
3.1.4. Alpha Range Determination	58
3.1.5. Solid State Nuclear Track Detector (CR-39)	59
3.1.6. Abrasive Chemical	60
3.2. DEVICES USED	61
3.2.1. Water Bath	61
3.2.2. Sensitive Balance	61
3.2.3. Measurement by Using Optical Microscope	62
3.3. OPTICAL MICROSCOPE SYSTEM FOR READING TRACKS	63
3.4. PREPARATION OF THE PROGRAMS	64

3.5.THE ADDITIVES	64
CHAPTER FOUR: RESULTS AND DISCUSSIONS	
4.1. RELATION BETWEEN THE ENERGY OF ALPHA PARTICLES AND THE DISTANCE BETWEEN THE SOURCE AND THE DETECTOR	65
4.2. RELATION BETWEEN THE ALPHA ENERGY AND THE RANGE OF ALPHA PARTICLES IN AIR	66
4.3. RELATIONSHIP BETWEEN THE FLUENCE OF ALPHA PARTICLES AND THE TRACK DENSITY FOR THE DIFFERENT ENERGIES AND THE ETCHING TIMES.	67
4.3.1. Relationship between the Fluence of Alpha Particles and the Track Density when the Etching Time Fixing at 2 h for the Different Energies.	67
4.3.2. Relationship between the Fluence of Alpha Particles and the Track Density when the Etching Time Fixing at 4 h for the Different Energies.	67
4.3.3. Relationship between the Fluence of Alpha Particles and the Track Density at Etching Times 5 and 6 h for the Different Energies.	68
4.3.4. Relationship between the Fluence of Alpha Particles and the Track Density at Etching Times 7 and 8 h for the Different Energies.	69
4.3.5. Relationship between the Fluence of Alpha Particles and the Track Density at Etching Times 9 and 10 h for the Different Energies.	70
4.3.6. Relationship between the Fluence of Alpha Particles and the Track Density when the Etching Time Fixing at 12 h for the Different Energies.	71
4.4. RELATIONSHIP BETWEEN THE ETCHING TIME AND THE TRACK DENSITY FOR THE ALL ENERGIES AT THE DIFFERENT FLUENCE OF ALPHA	72
4.5. RELATIONSHIP BETWEEN THE ETCHING TIMES AND THE TRACK DENSITY FOR THE DIFFERENT ENERGIES FROM 1 TO 5 MEV AND THE FLUENCE OF ALPHA PARTICLES	74
4.5.1. Relationship between the Etching Time and the Track Density for the Different Energies from 1 to 5 MeV at the Low Fluence of alpha.	74

4.5.2. Relationship between the Etching Time and the Track Density for the Different Energies from 1 to 5 MeV during the Incrementally Increased Fluence of Alpha.	75
4.5.3. Relationship between the Etching Time and the Track Density for the Different Energies from 1 to 5 MeV at the High Fluence of alpha.	76
4.6. RELATIONSHIP BETWEEN THE ENERGY OF ALPHA PARTICLES AND THE TRACK DIAMETER. 4.6.1. Relationship between the Energy of Alpha and the Track Diameter from the Low Fluence of alpha particles to the High Fluence.	77
4.7. RELATIONSHIP BETWEEN THE ETCHING TIMES AND THE TRACK DIAMETERS. 4.7.1. Relationship between the Etching Times and the Track Diameters from the Low Fluence of alpha particles to the High Fluence.	79
4.8. RELATIONSHIP BETWEEN THE ETCHING TIMES AND THE EFFICIENCY OF ALPHA PARTICLES FOR THE DIFFERENT ENERGIES.	81
4.9 RELATIONSHIP BETWEEN THE ETCHING TIMES AND ALL PARAMETERS.	85
4.9.1. Relationship between the Etching Time and the Bulk Etch Rate.	85
4.9.2. Relationship between the Etching Time and the Track Etch Rate.	87
4.9.3. Relationship between the Etching Time and the Track Etch Rate Ratio	88
4.9.4. Relationship between the Etching Times and the Critical Angle	90
4.9.5. Relationship between the Etching Time and the Track Length	91
4.9.6 Relationship between the Etching Time and the Track Depth	93
4.9.7. Relation between the Etching Times and the Etching Efficiency	94
4.10. RELATIONSHIP BETWEEN 1 ML OF THE DIFFERENT ADDITIVES AND HYDROXIDE SODIUM FOR THE ENERGY 3 MEV AFTER 6 h OF THE ETCHING TIME	96

4.10.1. Relation between the Different Additives and the Track Density and Diameter.	96
4.10.2. Relation between the Different Additives and the Bulk Etch Rate	98
4.10.3. Relation between the Different Additives and the Track Etch Rate	99
4.10.4. Relation between the Different Additives and the Track Etch Rate Ratio.	99
4.10.5. Relation between the Different Additives and the Critical Angle.	100
4.10.6. Relation between the Different Additives and the Track Depth and Length	101
4.10.7. Relation between the Different Additives and the etching Efficiency.	103
4.11. RELATIONSHIP BETWEEN 4 ML OF THE DIFFERENT ADDITIVES AND HYDROXIDE SODIUM FOR THE ENERGY 3 MEV AFTER 6 h OF THE ETCHING TIME.	104
4.11.1. Relation between the Different Additives and the Track Density and Diameter.	104
4.11.2. Relation between the Different Additives and the Bulk Etch Rate	106
4.11.3. Relation between the Different Additives and the Track Etch Rate	106
4.11.4. Relation between the Different Additives and the Track Etch Rate Ratio	107
4.11.5. Relation between the Different Additives and the Critical Angle	108
4.11.6. Relation between the Different Additives and the Track Depth and Length.	109
4.11.7. Relation between the Different Additives and the Etching Efficiency	111
REFERENCES	112
CONCLUSIONS	120
ARABIC SUMMARY	
FUTURE WORK AND RECOMMENDATIONS	

List of Figures

Figure No	Title	Page
Figure (1.1)	Ion–Explosion Spike Model	7
Figure (1.2)	Track Formation in Polymers	8
Figure (1.3)	Normally, particle track geometry penetrates a detector material.	11
Figure (1.4)	Diagram of Point Source	18
Figure (1.5)	Line Source	19
Figure (1.6)	Line Source	20
Figure (1.7)	Area Source	21
Figure (1.8)	Volume Source	23
Figure (1.9)	Spherical source	24
Figure (3.1)	Shows the ^{241}Am radiation facility in the National Institute of Standard, Egypt	56
Figure (3.2)	Different Collimators	59
Figure (3.3)	CR -39 Detector	60
Figure (3.4)	Water Bath	61
Figure (3.5)	Sensitive Balance	62
Figure (3.6)	Optical Microscope	62
Figure (3.7)	Optical Microscope System For Reading Tracks	63
Figure (4.1)	Relationship between the alpha energy and the distance.	66
Figure (4.2)	Relationship between the energy of alpha and the range in air.	66

Figure (4.3)	Relationship between the fluence of alpha particles and the track density at 2h etching time for different energies at 6.25 N NaOH at 70°C	67
Figure (4.4)	The relationship between the fluence of alpha and the track density at 4h etching time for different energies at 6.25 N NaOH at 70°C.	68
Figure (4.5)	Relationship between the fluence of alpha and the track density at 5h etching time for different energies at 6.25 N NaOH at 70°C	69
Figure (4.6)	Relationship between the fluence of alpha and the track density at 6h etching time for different energies at 6.25 N NaOH at 70°C.	69
Figure (4.7)	Relationship between the fluence of alpha and the track density at 6h etching time for different energies at 6.25 N NaOH at 70°C	70
Figure (4.8)	Relationship between the fluence of alpha and the track density at 8h etching time for different energies at 6.25 N NaOH at 70°C	70
Figure (4.9)	Relationship between the fluence of alpha and the track density at 9h etching time for different energies at 6.25 N NaOH at 70°C	71
Figure (4.10)	Relationship between the fluence of alpha and the track density at 10h etching time for different energies at 6.25 N NaOH at 70°C	71
Figure (4.11)	Relationship between the fluence of alpha and the track density at 12h etching time for different energies at 6.25 N NaOH at 70°C	72
Figure (4.12)	Relationship between the etching time and the track density in different exposure times for energy 1 MeV at 6.25 N NaOH at 70° C	73
Figure (4.13)	Relationship between the etching time and the track density in different exposure times for energy 2 MeV at 6.25 N NaOH at 70° C	73
Figure (4.14)	Relationship between the etching time and the track density in different exposure times for energy 3 MeV at 6.25 N NaOH at 70° C	73
Figure (4.15)	Relationship between the etching time and the track density in different exposure times for energy 4 MeV at 6.25 N NaOH at 70° C	73

Figure (4.16)	Relationship between the etching time and the track density in different exposure times for energy 1 MeV at 6.25 N NaOH at 70° C	74
Figure (4.17a)	Relationship between the etching time and the track density for the different energies from 1 MeV to 5 MeV during the low fluence of alpha at 6.25 N NaOH at 70°C	75
Figure (4.17b)	Relationship between the etching time and the track density for the different energies from 1 MeV to 5 MeV during the increased fluence of alpha at 6.25 N NaOH at 70°C	75
Figure (4.18)	Relationship between the etching time and the track density for the different energies from 1 MeV to 5 MeV during the incrementally increased fluence of alpha at 6.25 N NaOH at 70°C	76
Figure (4.19a)	Relationship between the etching time and the track density for the different energies from 1 MeV to 5 MeV during the high fluence of alpha at 6.25 N NaOH at 70°C	77
Figure (4.19b)	Relationship between the etching time and the track density for the different energies from 1 MeV to 5 MeV during the very high fluence of alpha at 6.25 N NaOH at 70°C	77
Figure (4.20a)	Relationship between the energies of alpha and the track diameter for the different etching times during the low fluence of alpha at 6.25 N NaOH at 70°C	78
Figure (4.20b)	Relationship between the energies of alpha and the track diameter for the different etching times during the incrementally increased fluence of alpha at 6.25 N NaOH at 70°C	78
Figure (4.20c)	Relationship between the energies of alpha and the track diameter for the different etching times during the high fluence of alpha at 6.25 N NaOH at 70°C	78
Figure (4.20d)	Relationship between the energies of alpha and the track diameter for the different etching times during the very high fluence of alpha at 6.25 N NaOH at 70°C	78

Figure (4.21a)	Relationship between the etching times and the track diameters for the different energies during the low fluence of alpha at 6.25 N NaOH at 70°C	80
Figure (4.21b)	Relationship between the etching times and the track diameters for the different energies during the incrementally increased fluence of alpha at 6.25 N NaOH at 70°C	80
Figure (4.21c)	Relationship between the etching times and the track diameters for the different energies during the high fluence of alpha at 6.25 N NaOH at 70°C	80
Figure (4.21d)	Relationship between the etching times and the track diameters for the different energies during the very high fluence of alpha at 6.25 N NaOH at 70°C	80
Figure (4.22a)	Relationship between the etching times and the efficiency of alpha for the different energies during the low fluence of alpha at 6.25 N NaOH at 70°C	84
Figure (4.22b)	Relationship between the etching times and the efficiency of alpha for the different energies during the incrementally increased fluence of alpha at 6.25 N NaOH at 70°C	84
Figure (4.22c)	Relationship between the etching times and the efficiency of alpha for the different energies during the high fluence of alpha at 6.25 N NaOH at 70°C	85
Figure (4.22d)	Relationship between the etching times and the efficiency of alpha for the different energies during the very high fluence of alpha at 6.25 N NaOH at 70°C	85
Figure (4.23a)	Relationship between the etching times and the bulk etch rate for the different energies during the low fluence of alpha at 6.25 N NaOH and 70°C	86
Figure (4.23b)	Relationship between the etching times and the bulk etch rate for the different energies during the incrementally increased fluence of alpha at 6.25 N NaOH and 70°C.	86